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Response
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TI-25320

Patent Amendment

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Park, et al.	Group Art Unit: 2814
Application No.: 09/173,129	Examiner: Peralta, G.
Filed: 10/15/1998	Tech Grp Fax: TC 2800 BF: 703-872-9318
Title: Selective Oxidation for Semiconductor Device Fabrication	I hereby certify that this correspondence is being <input type="checkbox"/> deposited with the United States Postal Service as first class mail in an envelope addressed to Box PG Pub, Commissioner for Patents, Washington, D.C. 20231, or <input checked="" type="checkbox"/> facsimile transmitted to the U.S. Patent and Trademark Office, on <u>7/25/02</u>
Attorney Docket No.: TI-25320	<u>Anderson Levine Lintel</u> <u>7/25/02</u> Name Date

Commissioner for Patents

Washington, D.C. 20231

RESPONSE UNDER 37 CFR 1.111

Dear Sir:

In response to the Office Action of March 25, 2002, please review this application with regard to the following Remarks.

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JUL 25 2002

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